





PATENT Customer No. 22,852 Attorney Docket No. 5225.0254

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAKESHI SHIBATA ET AL.) Group Art Unit: 1756
Application No.: 10/743,290)) Examiner: Unknown
Filed: December 23, 2003)) Confirmation No.: 7857 \
For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE AND EQUIPMENT FOR FABRICATING THE SAME	/)))

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), applicants bring to the attention of the Examiner the document on the attached listing. This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application.

A copy of the listed foreign document is attached.

Applicants respectfully request that the Examiner consider the listed document and indicate that it was considered by making an appropriate notation on the attached form.

An English-language Abstract of the Japanese publication is attached.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed document is material or constitutes "prior art." If the Examiner applies the document as prior art against any claim in the application and applicants determine that the cited document does not constitute "prior art" under United States law, applicants reserve the right to present to the office the relevant facts and law regarding the appropriate status of the document.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated:

Bv·

Richard V. Burquijar

Reg. No. 31

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IDS Form PTO/SB/08: Substitute for form 1449A/FI		m 1449A/PTO		Complete if Known		
		9 /	144	Application Number	10/743,290	·
INF	ORMATION D	ISCLO'S&	IRE .⋞	/Filing Date	December 23, 2003	
INFORMATION DISCLOSURE STATEMENT BY APPLICAN BETTALED TO		First Named Inventor	Takeshi Shibata			
STATEMENT DI ATTECAN				Art Unit	1756	
	(Use as many sheets	as necessary)		Examiner Name	Unknown	
Sheet	1	of	1	Attorney Docket Number	5225 0254	-

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS						
Examiner Cite No.1	Cite	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where	
	No.'	Number-Kind Code ² (if known)			Relevant Passages or Relevant Figures Appear	
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Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.1	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation ⁶
		JP 7-153657	6/16/95	Nikon Corp.		Abstract
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Cite		
No.¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶
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Examiner	 Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.